



**ELECTRONIC COPY**

LG782640808  
Report verification at igi.org



March 12, 2026

IGI Report Number **LG782640808**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **10.80 X 7.00 X 4.80 MM**

**GRADING RESULTS**

Carat Weight **4.02 CARATS**

Color Grade **D**

Clarity Grade **VVS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

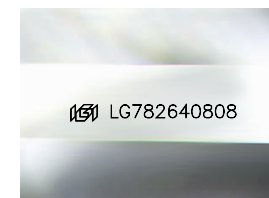
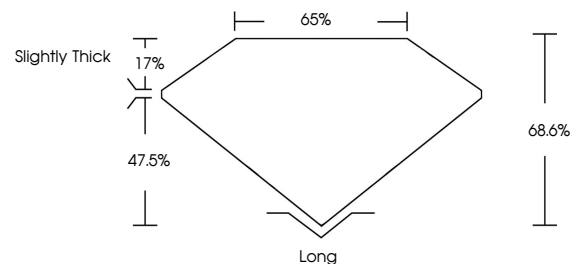
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG782640808**

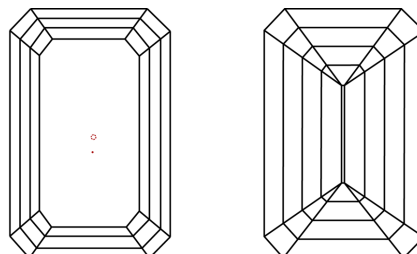
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

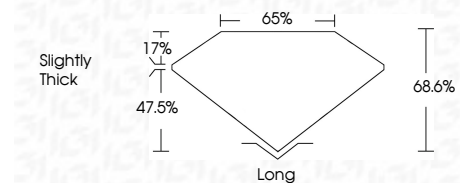
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



March 12, 2026  
IGI Report No **LG782640808**  
**EMERALD CUT**  
**4.02 CARATS**  
Carat Weight **D**  
Color Grade **VVS 1**  
Clarity Grade **68.6%**  
Depth **65%**  
Table **Slightly Thick**  
Girdle **Long**  
Culet **EXCELLENT**  
Polish **EXCELLENT**  
Symmetry **NONE**  
Fluorescence **NONE**  
Inscription(s) **IGI LG782640808**

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